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PATENT
Customer No. 22,852
Attorney Docket No. 8071.0007-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Takeshi MITSUISHI et al.) Group Art Unit: 2872
)
Application No.: 09/986,907) Examiner: J. Pritchett
)
Filed: November 13, 2001)
)
For: COMPOSITION FOR VAPOR)
DEPOSITION, METHOD FOR)
FORMING AN ANTIREFLECTION)
FILM, AND OPTICAL ELEMENT)

RECEIVED
FEB 19 2003
TECHNOLOGY CENTER 2800

Commissioner for Patents
Washington, DC 20231

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one month extension of time to reply to the Office
Action of October 22, 2002. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge
any additional required fees to our deposit account 06-0916.

02/12/2003 YPOLITE1 00000018 09986907

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110.00 OP

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: February 10, 2003

By: Charles E. Van Horn
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